IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeyoshi ISOGAI; Kimihiko YASUDA; Noriaki IWAKI;

Hiroshi KATSUMI

Application No.: New U.S. Patent Application

Filed: January 10, 2002

Docket No.: 111709

For: METHOD OF DETECTING POSITION OF ROTATION AXIS OF SUCTION NOZZLE,

AND ELECTRIC-COMPONENT MOUNTING SYSTEM

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of Japanese Patent Applications No. 2-57719 and No. 4-372199 is discussed in the present specification.
- 3. A concise explanation of the relevance of the Japanese Patent Application No. 11-40996 appears in the Appendix attached hereto.

Respectfully submitted,

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Date: January 10, 2002

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